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Atty. Docket No.: 042390.P4220

Patent



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Mark T. Bohr

U.S. Serial No: 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION
STRUCTURE AND METHOD OF
FABRICATION

Examiner: Oh, E.

Art Unit: 2822

Assistant Commissioner for Patents
and Trademarks
Washington, D.C. 20231

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AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed August 18, 1999. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks. Reconsideration and reexamination of the above-referenced application is respectfully requested.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231 on
December 20, 1999

Date of Deposit

Lola Rodriguez

Name of Person Mailing Correspondence

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Date

12/20/99